



“RESPONSE UNDER 37 CFR 1.116-  
EXPEDITED PROCEDURE EXAMINING  
GROUP 3742”

AF

Docket No. 221014US90 PCT  
IN RE APPLICATION OF: Yasuji HIRAMATSU, et al.  
SERIAL NO: 10/070,443  
FILED: June 24, 2002  
FOR: CERAMIC HEATER FOR A SEMICONDUCTOR PRODUCING/EXAMINING DEVICE, PROCESS OF  
PRODUCING THE CERAMIC HEATER, AND PRODUCTION SYSTEM OF THE CERAMIC HEATER

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:  
Transmitted herewith is an **AMENDMENT AFTER FINAL UNDER 37 C.F.R. 1.116** in the above-identified application.

- ☒ No additional fee is required  
☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.  
☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	12	MINUS	20	0	x \$50 =	\$0.00
INDEPENDENT	1	MINUS	3	0	x \$200 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$360 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$0.00

- ☐ A check in the amount of **\$0.00** is attached.  
☐ Credit card payment form is attached to cover the fees in the amount of **\$0.00**  
☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.  
☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

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GROUP 3742"

DOCKET NO: 221014US90 PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF: :  
Yasuji HIRAMATSU, et al. : EXAMINER: FUQUA, S.  
SERIAL NO.: 10/070,443 :  
FILED: June 24, 2002 : GROUP ART UNIT: 3742  
FOR: CERAMIC HEATER FOR A :  
SEMICONDUCTOR  
PRODUCING/EXAMINING  
DEVICE, PROCESS OF  
PRODUCING THE CERAMIC  
HEATER, AND PRODUCTION  
SYSTEM OF THE CERAMIC  
HEATER

AMENDMENT AFTER FINAL UNDER 37 CFR 1.116

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated January 25, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.